

PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Cabuz et al.

Serial No.:

09/749,171

Examiner: Simkovic, Viktor

Filed:

December 27, 2000

Group Art Unit: 2812

For:

THIN SILICON MICROMACHINED STRUCTURES

Docket No.:

H16-26635 (1100.1116101)

## REPLACEMENT AMENDMENT

Mail Stop Non-Fee Amendment Assistant Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

CERTIFICATE UNDER 37 C.F.R. 1.10: The undersigned hereby certifies that this paper or papers, as described herein, are being deposited in the United States Postal Service, "Express Mail Post Office to Addressee" having an Express Mail mailing label number of: EV315609051US, in an envelope addressed to: Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, on this 29th day of September, 2003.

By UMW 1 WWW 802 Lynn Thompson

Dear Sir/Madame:

This Amendment is a replacement to the Amendment sent August 28, 2003 and filed September 2, 2003 in response to the Official Action of the Examiner mailed May 28, 2003. This amendment was discussed with the Examiner during the week of September 22, 2003. Enclosed herewith is a Petition for a One-Month Extension of Time, extending the time for response to September 28,2003.

Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

10/06/2003 MDANTE1 00000061 500413 09749171

02 FC:1202 03 FC:1201 342.00 DA 336.00 DA



Application No. 09/749,171
Replacement Amendment dated September 29, 2003
Reply to Office Action of May 28, 2003

Remarks/Arguments begin on page 24 of this paper.